## Daisuke Nakamura

## List of Publications by Year in Descending Order

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The third column is the impact factor (IF) of the journal, and the fourth column is the number of citations of the article.

32	735	10	27
papers	citations	h-index	g-index
36 ext. papers	833 ext. citations	<b>4.2</b> avg, IF	4.11 L-index

#	Paper	IF	Citations
32	Mechanism and enhancement of anti-parasitic-reaction catalytic activity of tungsten-carbide-coated graphite components for the growth of bulk GaN crystals. <i>Applied Physics Express</i> , <b>2022</b> , 15, 045501	2.4	
31	Tungsten carbide layers deposited on graphite substrates via a wet powder process as anti-parasitic-reaction coatings for reactor components in GaN growth. <i>CrystEngComm</i> , <b>2020</b> , 22, 2632-	·2 <del>8</del> ·41	1
30	Growth of high-quality GaN by halogen-free vapor phase epitaxy. <i>Applied Physics Express</i> , <b>2020</b> , 13, 085	5 <b>0</b> 9 <sub>4</sub>	2
29	Transformation of hollow-core screw dislocations: transitional configuration of superscrew dislocations. <i>Japanese Journal of Applied Physics</i> , <b>2020</b> , 59, 095502	1.4	2
28	Resistive heater element made of highly durable TaC-coated graphite for high-temperature and highly corrosive processes: application to MOCVD GaN epitaxial growth. <i>Japanese Journal of Applied Physics</i> , <b>2019</b> , 58, 075509	1.4	4
27	Hansen Solubility Parameters of Stacked Silicanes Derived from Porous Silicon. ACS Omega, 2019, 4, 11	8 <b>3.8</b> -1	I8 <b>4</b> 3
26	Self-Assembled Single-Crystalline GaN Having a Bimodal Meso/Macropore Structure To Enhance Photoabsorption and Photocatalytic Reactions. <i>ACS Applied Materials &amp; Description Action Section</i> 11, 4233-	4247	9
25	Macro-defect-free homoepitaxial GaN growth through halogen-free vapor-phase epitaxy on native GaN seeds. <i>Journal of Crystal Growth</i> , <b>2018</b> , 494, 17-25	1.6	10
24	Liquid-Phase Exfoliation of Germanane Based on Hansen Solubility Parameters. <i>Chemistry of Materials</i> , <b>2018</b> , 30, 5333-5338	9.6	23
23	Porosity-controlled multilayer TaC coatings prepared via wet powder process for multi-functional reactor components in GaN crystal growth system. <i>Ceramics International</i> , <b>2018</b> , 44, 21284-21288	5.1	5
22	Ultrahigh-yield growth of GaN via halogen-free vapor-phase epitaxy. <i>Applied Physics Express</i> , <b>2018</b> , 11, 065502	2.4	7
21	Nontoxic organic solvents identified using an a priori approach with Hansen solubility parameters. <i>Chemical Communications</i> , <b>2017</b> , 53, 4096-4099	5.8	10
20	TaC-coated graphite prepared via a wet ceramic process: Application to CVD susceptors for epitaxial growth of wide-bandgap semiconductors. <i>Journal of Crystal Growth</i> , <b>2017</b> , 478, 163-173	1.6	12
19	Significant increase in GaN growth rate by halogen-free vapor phase epitaxy with porosity-controlled evaporator. <i>Applied Physics Express</i> , <b>2017</b> , 10, 095503	2.4	6
18	Origin and effective reduction of inversion domains in aluminum nitride grown by a sublimation method. <i>Journal of Crystal Growth</i> , <b>2017</b> , 478, 33-41	1.6	3
17	Tantalum carbide coating via wet powder process: From slurry design to practical process tests. Journal of the European Ceramic Society, <b>2017</b> , 37, 1175-1185	6	18
16	Halogen-free vapor phase epitaxy for high-rate growth of GaN bulk crystals. <i>Applied Physics Express</i> , <b>2017</b> , 10, 045504	2.4	10

## LIST OF PUBLICATIONS

15	Fabrication of large-sized TaC-coated carbon crucibles for the low-cost sublimation growth of large-diameter bulk SiC crystals. <i>Japanese Journal of Applied Physics</i> , <b>2017</b> , 56, 085504	1.4	7
14	Simple and quick enhancement of SiC bulk crystal growth using a newly developed crucible material. <i>Applied Physics Express</i> , <b>2016</b> , 9, 055507	2.4	14
13	Nanopipe formation as a result of boron impurity segregation in gallium nitride grown by halogen-free vapor phase epitaxy. <i>Journal of Applied Physics</i> , <b>2016</b> , 120, 245703	2.5	12
12	Sintered tantalum carbide coatings on graphite substrates: Highly reliable protective coatings for bulk and epitaxial growth. <i>Applied Physics Letters</i> , <b>2015</b> , 106, 082108	3.4	22
11	Direct determination of Burgers vector sense and magnitude of elementary dislocations by synchrotron white x-ray topography. <i>Journal of Applied Physics</i> , <b>2008</b> , 103, 013510	2.5	9
10	Topographic study of dislocation structure in hexagonal SiC single crystals with low dislocation density. <i>Journal of Crystal Growth</i> , <b>2007</b> , 304, 57-63	1.6	35
9	Investigation of carrier lifetime in 4H-SiC epilayers and lifetime control by electron irradiation. <i>Applied Physics Letters</i> , <b>2007</b> , 90, 202109	3.4	158
8	Synchrotron X-ray Topographic Analysis of Dislocation Structures in Bulk SiC Single Crystal. <i>Materials Science Forum</i> , <b>2006</b> , 527-529, 407-410	0.4	
7	Reduction of Dislocations in the Bulk Growth of SiC Crystals. <i>Materials Science Forum</i> , <b>2006</b> , 527-529, 3-8	0.4	9
6	Ultrahigh-quality single crystals of silicon carbide by alternate repetition of growth perpendicular to c-axis. <i>Microelectronic Engineering</i> , <b>2006</b> , 83, 139-141	2.5	2
5	Ultrahigh-quality silicon carbide single crystals. <i>Nature</i> , <b>2004</b> , 430, 1009-12	50.4	307
4	Impact of SiC Structural Defects on the Degradation Phenomenon of Bipolar SiC Devices. <i>Materials Science Forum</i> , <b>2003</b> , 433-436, 917-920	0.4	8
3	Local atomic arrangement of Pb and Sn on the Si(111)BB-(Pb,Sn) surface. <i>Materials Science and Engineering B: Solid-State Materials for Advanced Technology</i> , <b>2002</b> , 96, 145-149	3.1	9
2	Self-Healing Phenomenon of Micropipes in Silicon Carbide. <i>Materials Science Forum</i> , <b>2002</b> , 389-393, 103	3-1026	8
1	Self-recovery of monolayer Pb adsorbates on the Si(111)-1 <b>1</b> -Pb surface under ion irradiation at room temperature. <i>Surface Science</i> , <b>1999</b> , 425, 174-179	1.8	9